

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	1587	"427"/\$.ccls. and (((dielectric insulat\$3) same (heat\$3 thermal) same (diffus\$3 permeat\$3 dispers\$3 disseminat\$3 dissipat\$3))	US-PGPUB; USPAT	OR	ON	2005/11/17 16:21
L2	305	"427"/\$.ccls. and (((dielectric insulat\$3) same (heat\$3 thermal) same (diffus\$3 permeat\$3 dispers\$3 disseminat\$3 dissipat\$3) same (pattern\$3 remov\$3))	US-PGPUB; USPAT	OR	ON	2005/11/17 16:22
L3	63	430/312-321.ccls. and (((dielectric insulat\$3) same (heat\$3 thermal) same (diffus\$3 permeat\$3 dispers\$3 disseminat\$3 dissipat\$3) same (pattern\$3 remov\$3))	US-PGPUB; USPAT	OR	ON	2005/11/17 16:23
L4	53	430/312-321.ccls. and (((dielectric insulat\$3) with (diffus\$3 permeat\$3 dispers\$3 disseminat\$3 dissipat\$3)) same (heat\$3 thermal)) and ((dielectric insulat\$3) with (pattern\$3 remov\$3))	US-PGPUB; USPAT	OR	ON	2005/11/17 16:24
L5	374	("445"/\$.ccls. "427"/\$.ccls. 430/312-321.ccls.) and (((dielectric insulat\$3) with (diffus\$3 permeat\$3 dispers\$3 disseminat\$3 dissipat\$3)) same (heat\$3 thermal)) and ((dielectric insulat\$3) with (pattern\$3 remov\$3))	US-PGPUB; USPAT	OR	ON	2005/11/17 18:00
L6	120	("445"/\$.ccls. "427"/\$.ccls. 430/312-321.ccls.) and (((dielectric insulat\$3) with (diffus\$3 permeat\$3 dispers\$3 disseminat\$3 dissipat\$3)) same (heat\$3 thermal)) and ((dielectric insulat\$3) with (pattern\$3 remov\$3)) and (cathode ((electron field) with (emission emissive emitter source emitting)))	US-PGPUB; USPAT	OR	ON	2005/11/17 18:07
L7	83	(((dielectric insulat\$3) with (diffus\$3 permeat\$3 dispers\$3 impregnat\$3 doping dopant disseminat\$3 dissipat\$3)) same (heat\$3 thermal)) and ((dielectric insulat\$3) with (pattern\$3 remov\$3)) and (cathode ((electron field) with (emission emissive emitter source emitting)))	EPO; JPO; DERWENT	OR	ON	2005/11/17 17:55
L8	101	("445"/\$.ccls. "427"/\$.ccls. 430/312-321.ccls.) and (((dielectric insulat\$3) with (impregnat\$3)) same (heat\$3 thermal)) and ((dielectric insulat\$3) with (pattern\$3 remov\$3))	US-PGPUB; USPAT	OR	ON	2005/11/17 18:01
L9	25	("216"/\$.ccls.) and (((dielectric insulat\$3) with (diffus\$3 impregnat\$3 permeat\$3 dispers\$3 disseminat\$3 dissipat\$3)) same (heat\$3 thermal)) and ((dielectric insulat\$3) with (pattern\$3 remov\$3)) and (cathode ((electron field) with (emission emissive emitter source emitting)))	US-PGPUB; USPAT	OR	ON	2005/11/17 18:08
S1	4967	((penetrat\$3 permeable permeat\$3 diffus\$4) with (pattern\$4 etch\$3) with (dielectric insulat\$3)) and (cathode electrode)	US-PGPUB; USPAT	OR	ON	2004/10/16 15:41
S2	2454	((penetrat\$3 permeable permeat\$3 diffus\$4) with (pattern\$4 etch\$3) with (dielectric insulat\$3)) same (cathode electrode)	US-PGPUB; USPAT	OR	ON	2004/10/16 15:41
S3	25	(((penetrat\$3 permeable permeat\$3 diffus\$4) with (pattern\$4 etch\$3) with (dielectric insulat\$3)) same (cathode electrode)) and "156"/\$.ccls.	US-PGPUB; USPAT	OR	ON	2004/10/16 15:46

S4	1081	(((penetrat\$3 permeable permeat\$3 diffus\$4) with (pattern\$4 etch\$3) with (dielectric insulat\$3)) same (cathode electrode)))	EPO; JPO; DERWENT	OR	ON	2004/10/16 15:46
S5	15	(((penetrat\$3 permeable permeat\$3 diffus\$4) with (pattern\$4 etch\$3) with (thick near3 (dielectric insulat\$3))) same (cathode electrode)))	EPO; JPO; DERWENT	OR	ON	2004/10/16 15:50
S6	1	"5047313".pn.	US-PGPUB; USPAT	OR	ON	2004/10/16 15:54
S7	0	(multi\$layer\$3 near3 cathode) and (dielectric insulat\$3)	US-PGPUB; USPAT	OR	ON	2004/10/16 15:55
S8	801	(multi\$layer\$3 with cathode) and (dielectric insulat\$3)	US-PGPUB; USPAT	OR	ON	2004/10/16 15:55
S9	203	(multi\$layer\$3 near3 cathode) and (dielectric insulat\$3)	US-PGPUB; USPAT	OR	ON	2004/10/16 15:55
S10	67	(multi\$layer\$3 near3 cathode) and (dielectric insulat\$3) and ("313"/\$.ccls.)	US-PGPUB; USPAT	OR	ON	2004/10/16 15:59
S11	7	(multi\$layer\$3 near3 cathode) and (thick near3 (dielectric insulat\$3 isolat\$3)) and ("313"/\$.ccls.)	US-PGPUB; USPAT	OR	ON	2004/10/16 16:00
S12	333	((thick near3 (dielectric insulat\$3 isolat\$3)) thick\$dielectric) and (cathode electrode) and (((electron field) near3 (emitting emission emissive emitter))) and ("313"/\$.ccls.)	US-PGPUB; USPAT	OR	ON	2004/10/16 16:40
S13	82	(((thick near3 (dielectric insulat\$3 isolat\$3)) thick\$dielectric) same pattern\$3) and (cathode electrode) and (((electron field) near3 (emitting emission emissive emitter))) and ("313"/\$.ccls.)	US-PGPUB; USPAT	OR	ON	2004/10/16 17:11
S14	22	("3731131" "3998678" "4193013" "4345181" "4498952" "4551649" "4683399" "5019003" "5129850" "5138220" "5141460" "5180951" "5190796" "5199918" "5202571" "5227699" "5249340" "5252833" "5278475" "5371431" "5449970" "5451830").PN.	USPAT	OR	ON	2004/10/16 16:45
S15	4	(((thick near3 (dielectric insulat\$3 isolat\$3)) thick\$dielectric) same pattern\$3) and (cathode electrode) and (((electron field) near3 (emitting emission emissive emitter)))	EPO; JPO; DERWENT	OR	ON	2004/10/16 17:08
S16	46	(((thick near3 (dielectric insulat\$3 isolat\$3)) thick\$dielectric) and (cathode electrode) and (((electron field) near3 (emitting emission emissive emitter)))	EPO; JPO; DERWENT	OR	ON	2004/10/16 17:08
S17	3	(((thick near3 (dielectric insulat\$3 isolat\$3)) thick\$dielectric) same pattern\$3) and (cathode electrode) and (((electron field) near3 (emitting emission emissive emitter))) and ("216"/\$.ccls.)	US-PGPUB; USPAT	OR	ON	2004/10/16 17:13

S18	62	(((thick near3 (dielectric insulat\$3 isolat\$3)) thick\$dielectric) with pattern\$3 and (cathode electrode) and (((electron field) near3 (emitting emission emissive emitter))))	US-PGPUB; USPAT	OR	ON	2004/10/16 17:21
S19	4	("3970887" "4513308" "5266530" "5358908").PN.	USPAT	OR	ON	2004/10/16 17:13
S20	3584	((dielectric insulat\$3 isolat\$3) with pattern\$3) and (cathode electrode) and (((electron field) near3 (emitting emission emissive emitter))))	US-PGPUB; USPAT	OR	ON	2004/10/16 17:22
S21	88	((dielectric insulat\$3 isolat\$3) with pattern\$3) and (cathode electrode) and (((electron field) near3 (emitting emission emissive emitter)))) and ("216"/\$.ccls.)	US-PGPUB; USPAT	OR	ON	2004/10/16 19:24
S22	19	((dielectric insulat\$3 isolat\$3) with thick with pattern\$3) and (216/13,17,62, 87,95.ccls.)	US-PGPUB; USPAT	OR	ON	2004/10/16 19:25
S23	19	((dielectric insulat\$3 isolat\$3) with thick) and (216/62.ccls.)	US-PGPUB; USPAT	OR	ON	2004/10/16 19:26
S24	151	((dielectric insulat\$3 isolat\$3)) and (216/62.ccls.)	US-PGPUB; USPAT	OR	ON	2004/10/16 19:26
S25	91	((dielectric insulat\$3 isolat\$3)) and (cathode electrode conductor) and (216/62.ccls.)	US-PGPUB; USPAT	OR	ON	2004/10/16 19:33
S26	1371	((diffus\$3 near3 (pattern\$3 etch\$3)) same (insulat\$3 dielectric)) and (cathode electrode)	US-PGPUB; USPAT	OR	ON	2004/07/20 11:18
S27	5	((diffus\$3 near3 (pattern\$3 etch\$3)) same (insulat\$3 dielectric)) and (cathode electrode) and "445"/\$.ccls.	US-PGPUB; USPAT	OR	ON	2004/07/20 11:19
S28	20	((diffus\$3 near3 (pattern\$3 etch\$3)) same (insulat\$3 dielectric)) and (cathode electrode) and "430"/\$.ccls.	US-PGPUB; USPAT	OR	ON	2004/07/20 11:21
S29	31	((diffus\$3 near3 (pattern\$3 etch\$3)) same (insulat\$3 dielectric)) and (cathode electrode) and "216"/\$.ccls.	US-PGPUB; USPAT	OR	ON	2004/07/20 11:24
S30	49	((diffus\$3 near3 (pattern\$3 etch\$3)) same (insulat\$3 dielectric)) and (cathode electrode) and "430"/\$.ccls.) (((diffus\$3 near3 (pattern\$3 etch\$3)) same (insulat\$3 dielectric)) and (cathode electrode) and "216"/\$.ccls.)	US-PGPUB; USPAT	OR	ON	2004/07/20 11:21
S31	113	((diffus\$3 with (pattern\$3 etch\$3)) same (insulat\$3 dielectric)) and (cathode electrode) and "216"/\$.ccls.	US-PGPUB; USPAT	OR	ON	2004/07/20 11:24
S32	198	((diffus\$3 with (pattern\$3 etch\$3)) same (insulat\$3 dielectric)) and (cathode electrode) and ("216"/\$.ccls. "430"/\$.ccls. "445"/\$.ccls.)	US-PGPUB; USPAT	OR	ON	2004/07/20 11:24
S33	128	(diffus\$3 with (pattern\$3 etch\$3) with (insulat\$3 dielectric)) and (cathode electrode) and ("216"/\$.ccls. "430"/\$.ccls. "445"/\$.ccls.)	US-PGPUB; USPAT	OR	ON	2004/07/20 11:50

S34	42	(actinic near3 (radiat\$3)) and "445"/\$.ccls.	US-PGPUB; USPAT	OR	ON	2004/07/20 11:51
S35	42	(actinic near3 (radiat\$3)) and "445"/\$.ccls.	US-PGPUB; USPAT	OR	ON	2004/07/20 11:51
S36	2	(actinic near3 (radiat\$3)) and "445"/\$.ccls.	USOCR	OR	ON	2004/07/20 11:51
S37	13	((actinic near3 (radiat\$3)) same (dielectric insulat\$3)) and "445"/\$.ccls.	US-PGPUB; USPAT	OR	ON	2004/07/20 13:35
S38	112	((actinic near3 (radiat\$3)) same (dielectric insulat\$3)) and ("438"/\$.ccls. "216"/\$.ccls. "430"/\$.ccls. "445"/\$.ccls.)	US-PGPUB; USPAT	OR	ON	2004/07/20 13:36
S39	140	((actinic near3 (radiat\$3 irradiat\$3 expos\$3 develop\$4)) same (dielectric insulat\$3)) and ("438"/\$.ccls. "216"/\$.ccls. "430"/\$.ccls. "445"/\$.ccls.)	US-PGPUB; USPAT	OR	ON	2004/07/20 13:37
S40	66	((actinic near3 (radiat\$3 irradiat\$3 expos\$3 develop\$4)) same (dielectric insulat\$3)) and ("438"/\$.ccls. "216"/\$.ccls. "430"/\$.ccls. "445"/\$.ccls.) and (cathode electrode)	US-PGPUB; USPAT	OR	ON	2004/07/20 13:38
S41	16	(actinic with (radiat\$3 irradiat\$3 expos\$3 develop\$4) with (dielectric insulat\$3)) and ("438"/\$.ccls. "216"/\$.ccls. "430"/\$.ccls. "445"/\$.ccls.) and (cathode electrode)	US-PGPUB; USPAT	OR	ON	2004/07/20 16:01
S42	10	(actinic with (radiat\$3 irradiat\$3 expos\$3 develop\$4) with (dielectric insulat\$3)) and ("313"/\$.ccls.) and (cathode electrode)	US-PGPUB; USPAT	OR	ON	2004/07/20 15:53
S43	20	(actinic with (radiat\$3 irradiat\$3 expos\$3 develop\$4) with (dielectric insulat\$3)) and (cathode electrode) and ((field electron) near3 (emitter source emission emitting emissive))	US-PGPUB; USPAT	OR	ON	2004/07/20 16:12
S44	2	(actinic same (radiat\$3 irradiat\$3 expos\$3 develop\$4) same (dielectric insulat\$3)) and (cathode electrode) and ((field electron) near3 (emitter source emission emitting emissive))	EPO; JPO; DERWENT	OR	ON	2004/07/20 16:12
S45	1	1998-532288.NRAN.	DERWENT	OR	OFF	2004/07/20 16:12
S46	249	((diffusion with pattern\$3) same (dielectric insulat\$3)) and ((field electron) near3 (emission source emissive emitting))	US-PGPUB; USPAT	OR	ON	2004/07/22 15:44
S47	699	((diffusion same pattern\$3) same (dielectric insulat\$3)) and ((field electron) near3 (emission source emissive emitting))	US-PGPUB; USPAT	OR	ON	2004/07/22 15:44
S48	0	(diffus\$4 same (remov\$3 pattern\$3) same actinic same (dielectric insulat\$3)) and ((field electron) near3 (emission source emissive emitting) near3 (display device panel))	US-PGPUB; USPAT	OR	ON	2004/07/22 15:47

S49	2	(diffus\$4 same (remov\$3 pattern\$3) same actinic same (dielectric insulat\$3)) and ((field electron) near3 (emison source emissive emitting))	US-PGPUB; USPAT	OR	ON	2004/07/22 15:47
S50	62	((difus\$3patern\$3 (diffus\$3 near3 pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and (FED ((electron field) near3 (source emitting emission emissive emitter)))	US-PGPUB; USPAT	OR	ON	2004/10/08 14:03
S51	702	((difus\$3patern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and (FED ((electron field) near3 (source emitting emission emissive emitter)))	US-PGPUB; USPAT	OR	ON	2004/10/08 14:03
S52	23	((difus\$3patern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and (((electron field) near3 (source emitting emission emissive emitter))) and ("445"/\$.ccls. "313"/\$.ccls. "430"/\$.ccls.)	US-PGPUB; USPAT	OR	ON	2004/10/08 14:20
S53	1	"5032216".pn.	US-PGPUB; USPAT	OR	ON	2004/10/08 14:15
S54	4	"5209814".pn. "5260163".pn. "5275689".pn. "5306756".pn.	US-PGPUB; USPAT	OR	ON	2004/10/08 14:16
S55	455	((difus\$3patern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and (((electron field) near3 (source emitting emission emissive emitter)))	US-PGPUB; USPAT	OR	ON	2004/10/08 14:36
S56	7	((difus\$3patern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and (((electron field) near3 (source emitting emission emissive emitter))) and "216"/\$.ccls.	US-PGPUB; USPAT	OR	ON	2004/10/08 14:43
S57	0	((difus\$3patern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and (((electron field) near3 (source emitting emission emissive emitter))) and "524"/\$.ccls.	US-PGPUB; USPAT	OR	ON	2004/10/08 14:42
S58	1658	((difus\$3patern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and (electrode cathode) and ("430"/\$.ccls. "445"/\$.ccls. "313"/\$.ccls. "438"/\$.ccls. "216"/\$.ccls.)	US-PGPUB; USPAT	OR	ON	2004/10/08 14:43
S59	455	((diffus\$3patern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and (((electron field) near3 (source emitting emission emissive emitter)))	US-PGPUB; USPAT	OR	ON	2004/10/08 14:44
S60	455	((diffus\$3patern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and (((electron field) near3 (source emitting emission emissive emitter)))	US-PGPUB; USPAT	OR	ON	2004/10/08 14:44
S61	455	((diffus\$3patern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and (((electron field) near3 (source emitting emission emissive emitter)))	US-PGPUB; USPAT	OR	ON	2004/10/08 14:45

S62	14	((diffus\$pattern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and (((electron field) near3 (source emitting emission emissive emitter))))	EPO; JPO; DERWENT	OR	ON	2004/10/08 14:58
S63	22	((diffus\$pattern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and (electrode cathode anode)	EPO; JPO; DERWENT	OR	ON	2004/10/08 15:03
S64	766	((diffus\$pattern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and (electrode cathode anode)	EPO; JPO; DERWENT	OR	ON	2004/10/08 15:03
S65	763	((diffus\$pattern\$3 (diffus\$3 with pattern\$3)) same (insulat\$3 dielectric isolat\$3)) and (electrode cathode)	EPO; JPO; DERWENT	OR	ON	2004/10/08 15:04
S66	471	((diffus\$pattern\$3 (diffus\$3 with pattern\$3)) with (insulat\$3 dielectric isolat\$3)) and (electrode cathode)	EPO; JPO; DERWENT	OR	ON	2004/10/08 15:05
S67	6	((diffus\$pattern\$3 (diffus\$3 with pattern\$3)) with (insulat\$3 dielectric isolat\$3)) and (cathode)	EPO; JPO; DERWENT	OR	ON	2004/10/08 15:07
S68	228	((diffus\$pattern\$3 (diffus\$3 with pattern\$3)) with (insulat\$3 dielectric isolat\$3)) and (cathode)	US-PGPUB; USPAT	OR	ON	2004/10/08 15:08
S69	2	((diffus\$pattern\$3 (diffus\$3 with pattern\$3)) with paste with (insulat\$3 dielectric isolat\$3)) and (cathode)	US-PGPUB; USPAT	OR	ON	2004/10/08 15:53
S70	3	("5032216" "5209814" "5275689").PN.	USPAT	OR	ON	2004/10/08 15:20
S71	5	"5385631".URPN.	USPAT	OR	ON	2004/10/08 15:21
S72	4	("5032216" "5037723" "5136207" "5385631").PN.	USPAT	OR	ON	2004/10/08 15:22
S73	5	"5385631".URPN.	USPAT	OR	ON	2004/10/08 15:50
S74	4	"5635334".URPN.	USPAT	OR	ON	2004/10/08 15:50
S75	4	("5032216" "5037723" "5136207" "5385631").PN.	USPAT	OR	ON	2004/10/08 15:51
S76	13	((diffus\$pattern\$3 (diffus\$3 with pattern\$3)) with paste with (insulat\$3 dielectric isolat\$3)) and (cathode electrode)	US-PGPUB; USPAT	OR	ON	2004/10/08 15:54
S77	74	(pattern\$3 with thick with (dielectric insulat\$3 isolat\$3)) and (cathode electrode) and (((electron field) near3 (source emitting emission emissive emitter)))) and ("313"/\$.ccls. "445"/\$.ccls.)	US-PGPUB; USPAT	OR	ON	2004/10/08 16:03
S78	32	(pattern\$3 with (thick near3 (dielectric insulat\$3 isolat\$3))) and (cathode electrode) and (((electron field) near3 (source emitting emission emissive emitter)))) and ("313"/\$.ccls. "445"/\$.ccls.)	US-PGPUB; USPAT	OR	ON	2004/10/08 16:08

S79	372	((thick near3 (dielectric insulat\$3 isolat\$3))) and (cathode electrode) and (((electron field) near3 (emitting emission emissive emitter))) and ("313"/\$.ccls. "445"/\$.ccls.)	US-PGPUB; USPAT	OR	ON	2004/10/08 16:13
S80	66	((thick near3 (dielectric insulat\$3 isolat\$3))) same (conventional known)) and (cathode electrode) and (((electron field) near3 (emitting emission emissive emitter))) and ("313"/\$.ccls. "445"/\$.ccls.)	US-PGPUB; USPAT	OR	ON	2004/10/08 16:27
S81	0	(thick\$dielectric same (conventional known)) and (cathode electrode) and (((electron field) near3 (emitting emission emissive emitter))) and ("313"/\$.ccls. "445"/\$.ccls.)	US-PGPUB; USPAT	OR	ON	2004/10/08 16:28
S82	0	(thick\$dielectric) and (cathode electrode) and (((electron field) near3 (emitting emission emissive emitter)))	US-PGPUB; USPAT	OR	ON	2004/10/16 16:00
S83	0	(thick\$dielectric) and (cathode electrode) and (((electron field) near3 (emitting emission emissive emitter)))	EPO; JPO; DERWENT	OR	ON	2004/10/08 16:28
S84	9	(thick near3 dielectric) and (cathode electrode) and (((electron field) near3 (emitting emission emissive emitter)))	EPO; JPO; DERWENT	OR	ON	2004/10/08 16:31
S85	72	((thick near3 dielectric) same pattern\$3) and (cathode electrode) and (((electron field) near3 (emitting emission emissive emitter)))	US-PGPUB; USPAT	OR	ON	2004/10/08 16:32
S86	7657	(cathode electrode) and ((insulat\$3 dielectric insolat\$3) same diffus\$3 same pattern\$3)	US-PGPUB; USPAT	OR	ON	2005/04/19 15:22
S87	11926	(cathode electrode) and ((insulat\$3 dielectric insolat\$3) same diffus\$3 same develop\$3 expos\$3 pattern\$3))	US-PGPUB; USPAT	OR	ON	2005/04/19 15:23
S88	10309	((cathode electrode) same (insulat\$3 dielectric insolat\$3)) and ((insulat\$3 dielectric insolat\$3) same diffus\$3 same (develop\$3 expos\$3 pattern\$3))	US-PGPUB; USPAT	OR	ON	2005/04/19 15:23
S89	9171	((cathode electrode) with (insulat\$3 dielectric insolat\$3)) and ((insulat\$3 dielectric insolat\$3) same diffus\$3 same (develop\$3 expos\$3 pattern\$3))	US-PGPUB; USPAT	OR	ON	2005/04/19 15:23
S90	5152	((cathode electrode) with (insulat\$3 dielectric insolat\$3)) and (((insulat\$3 dielectric insolat\$3) with diffus\$3) same (develop\$3 expos\$3 pattern\$3))	US-PGPUB; USPAT	OR	ON	2005/04/19 15:24
S91	68	((cathode electrode) with (insulat\$3 dielectric insolat\$3)) and (((insulat\$3 dielectric insolat\$3) with diffus\$3) same (develop\$3 expos\$3 pattern\$3)) and "430"/\$.ccls.	US-PGPUB; USPAT	OR	ON	2005/04/19 16:28
S92	8	("5032216" "5037723" "5136207" "5385631").PN. OR ("5635334").URPN.	US-PGPUB; USPAT; USOCR	OR	ON	2005/04/19 15:28
S93	1228	((cathode electrode) with (insulat\$3 dielectric insolat\$3)) and (((insulat\$3 dielectric insolat\$3) with diffus\$3) same (develop\$3 expos\$3 pattern\$3))	EPO; JPO; DERWENT	OR	ON	2005/04/19 15:47

S94	88	((cathode electrode) with (insulat\$3 dielectric insulat\$3)) and (((insulat\$3 dielectric insulat\$3) with diffus\$3) same (develop\$3 expos\$3 pattern\$3)) and ((electron field) with (emitting emissive source emission))	EPO; JPO; DERWENT	OR	ON	2005/04/19 16:03
S95	93	((cathode electrode) same (insulat\$3 dielectric insulat\$3)) and (((insulat\$3 dielectric insulat\$3) with diffus\$3) same (develop\$3 expos\$3 pattern\$3)) and ((electron field) with (emitting emissive source emission))	EPO; JPO; DERWENT	OR	ON	2005/04/19 16:05
S96	5	S95 not S94	EPO; JPO; DERWENT	OR	ON	2005/04/19 16:04
S97	109	((cathode electrode) same (insulat\$3 dielectric insulat\$3)) and (((insulat\$3 dielectric insulat\$3) with diffus\$3) same (etch\$3 remov\$3)) and ((electron field) with (emitting emissive source emission))	EPO; JPO; DERWENT	OR	ON	2005/04/19 16:05
S98	90	((cathode electrode) with (insulat\$3 dielectric insulat\$3)) and (((insulat\$3 dielectric insulat\$3) with diffus\$3) same (develop\$3 expos\$3 pattern\$3)) and "427"/\$.ccls.	US-PGPUB; USPAT	OR	ON	2005/04/19 16:29
S99	1	1998-532288.NRAN.	DERWENT	OR	ON	2005/05/02 08:52
S100	1	"20040027053"	US-PGPUB; USPAT	OR	ON	2005/05/02 08:59
S101	169	cathode and ((dielectric insulat\$3) same (paste slurry) same (pattern\$3 imaging) same (remov\$3 etch\$3)) and print\$3	US-PGPUB; USPAT	OR	ON	2005/05/02 09:11
S102	12	("4347306" "5485038" "5698470").PN. OR ("6010956").URPN.	US-PGPUB; USPAT; USOCR	OR	ON	2005/05/02 09:07
S103	17	cathode and ((dielectric insulat\$3) and (paste slurry) and (pattern\$3 imaging) and (remov\$3 etch\$3))	EPO; JPO; DERWENT	OR	ON	2005/05/02 09:13
S104	1002	(electrode cathode) and ((dielectric insulat\$3) same (paste slurry) same (pattern\$3 photo\$sensitive imag\$3) same (remov\$3 etch\$3))	US-PGPUB; USPAT; USOCR	OR	ON	2005/05/02 09:15
S105	1215	(electrode cathode) and ((dielectric insulat\$3) same (paste slurry) same (pattern\$3 photo\$sensitive imag\$3)) and ((dielectric insulat\$3) with (remov\$3 etch\$3))	US-PGPUB; USPAT; USOCR	OR	ON	2005/05/02 09:15
S106	472	(electrode cathode) and ((dielectric insulat\$3) with (paste slurry) with (pattern\$3 photo\$sensitive imag\$3)) and ((dielectric insulat\$3) with (remov\$3 etch\$3))	US-PGPUB; USPAT; USOCR	OR	ON	2005/05/02 09:16

S10 7	30	(electrode cathode) and ((dielectric insulat\$3) with (paste slurry) with (pattern\$3 photo\$sensitive imag\$3)) and ((dielectric insulat\$3) with (remov\$3 etch\$3)) and "427"/\$.ccls.	US-PGPUB; USPAT; USOCR	OR	ON	2005/05/02 09:19
S10 8	41	(electrode cathode) and ((dielectric insulat\$3) same ((paste slurry) with (pattern\$3 photo\$sensitive imag\$3))) and ((dielectric insulat\$3) with (remov\$3 etch\$3)) and "427"/\$.ccls.	US-PGPUB; USPAT; USOCR	OR	ON	2005/05/02 09:20
S10 9	76	(electrode cathode) and ((dielectric insulat\$3) same ((paste slurry) with (pattern\$3 photo\$sensitive imag\$3))) and ((dielectric insulat\$3) with (remov\$3 etch\$3)) and ("430"/\$.ccls. "427"/\$.ccls.)	US-PGPUB; USPAT; USOCR	OR	ON	2005/05/02 09:29
S11 0	46	S109 not S107	US-PGPUB; USPAT; USOCR	OR	ON	2005/05/02 09:20
S11 1	60	(electrode cathode) and ((dielectric insulat\$3) same ((paste slurry) with (pattern\$3 photo\$sensitive imag\$3))) and ((dielectric insulat\$3) with (remov\$3 etch\$3))	EPO; JPO; DERWENT	OR	ON	2005/05/02 10:26